



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/881,408
Confirmation No.....8492
Filing Date June 13, 2001
Inventor..... Kie Y. Ahn, et al
Assignee..... Micron Technology, Inc.
Group Art Unit.....2814
ExaminerT. Le
Attorney's Docket No.MI22-1534
Customer No.021567
Title: A Dielectric Layer Forming Method and Devices Formed Therewith

RESPONSE TO NOVEMBER 19, 2003 OFFICE ACTION

To: Commissioner for Patents
PO Box 1450
Art Unit 2814
Alexandria, VA 22313-1450

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS

No amendments.

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